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TECHNOLOGY CENTER 2800

PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2851

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenji NISHI

Application No.: 08/994,758

Filed: December 19, 1997

For: PROJECTION EXPOSURE APPARATUS

Group Art Unit: 2851

Examiner: A. Mathews

Docket No.: 110157.99

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AMENDMENT AFTER FINAL REJECTION IN REISSUE APPLICATION

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the Office Action dated January 3, 2002, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

IN THE CLAIMS:

Please replace claim 37 as follows:

37. (Three Times Amended) A scanning exposure apparatus in which a first
object is moved in a first direction and a second object is moved in a second direction for
scanning exposure, the apparatus comprising:
a projection system for the scanning exposure, which is disposed in an optical
path of an exposure beam, the first object being provided on one side of the projection system
and the second object being provided on the other side of the projection system;

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